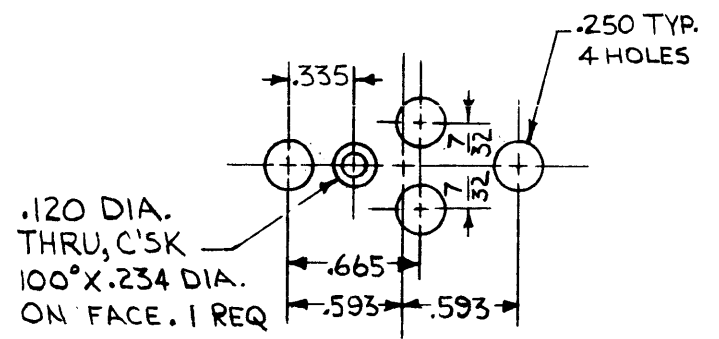
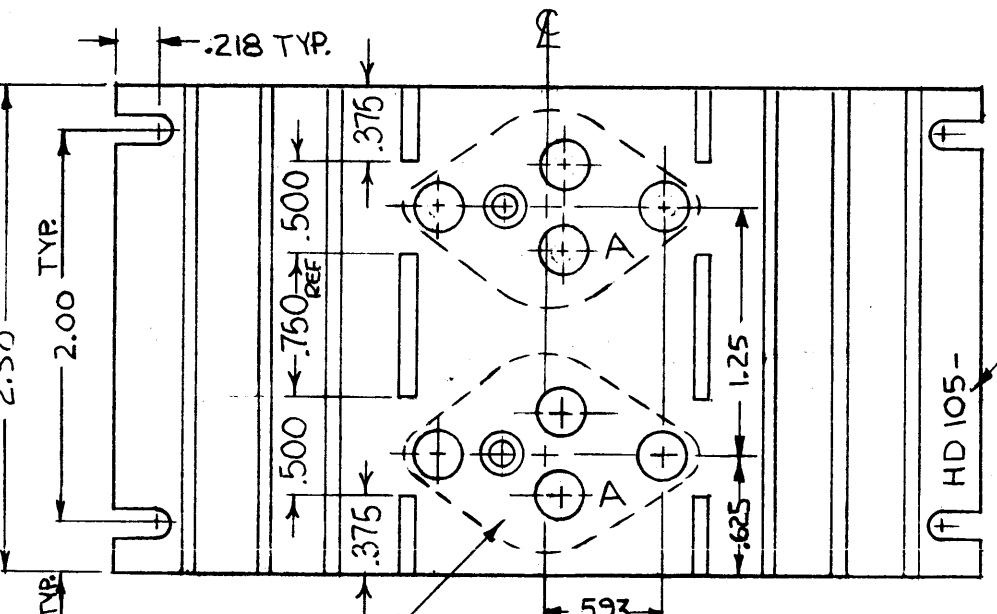
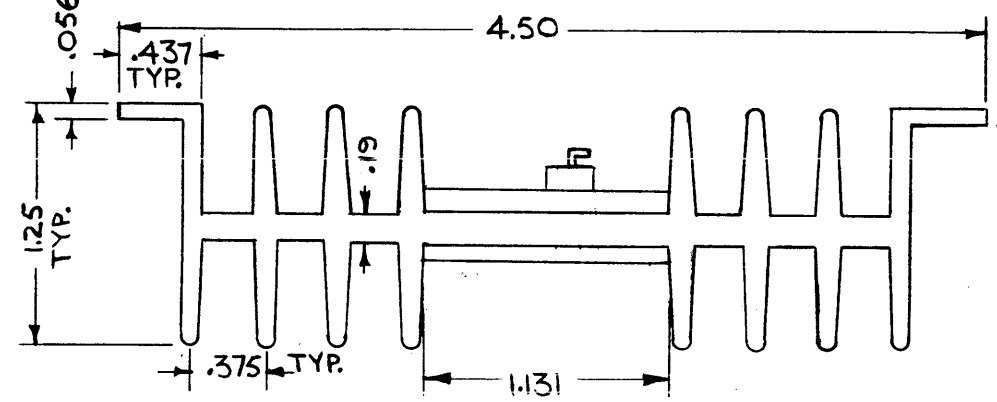
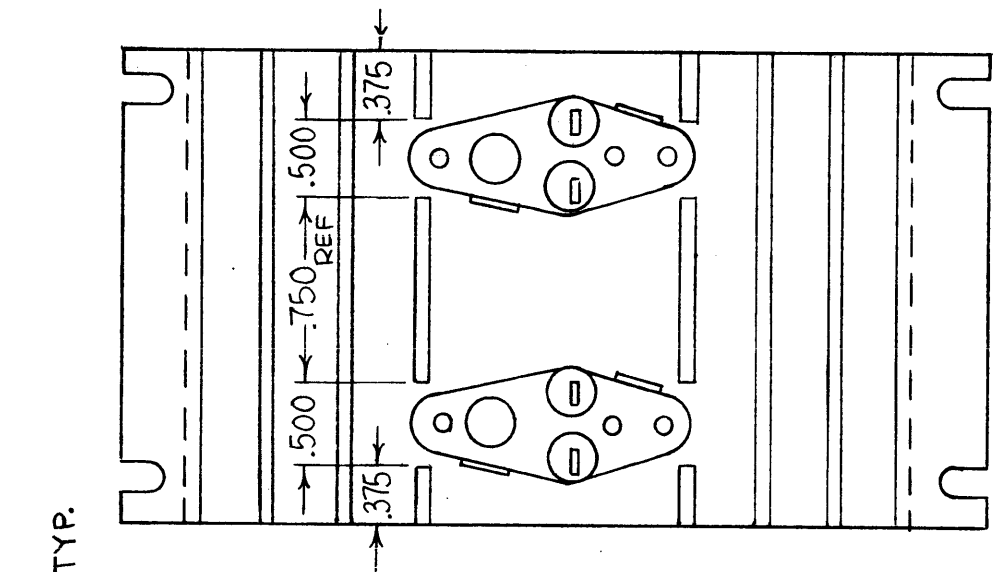


STANDARD DRAWING

A
HD105

REVISIONS						
SYM	DESCRIPTION	DATE	E.M.N. NO.	DRAFT	CHKD	APPD
X	EXPERIMENTAL RELEASE	9-30-66	X	RME		
Ø	ORIG RELEASE FOR PROD	10/11/66	Ø	CV		
A	2.00 DIM WAS 2.25, NOTE 4 WAS 8080-161	10/30/67	18576	NEI	WPA	EFM



DETAIL "A"
(2 REQ)

- NOTES:**
- 1- WAFER MATERIAL: BERYLLIUM OXIDE.
 - 2- SURFACE FOR BERYLLIUM OXIDE WAFER MUST BE FLAT.
 - 3- SOCKET & WAFER TO ACCEPT TO-3 TYPE SEMI-CONDUCTOR.
 - 4- SOCKET-AUGAT 8043-1G3 OR EQUIV.

MARK TMC PART /NO.
1/8 HIGH GOTHIC W/LATEST
REVISION LETTER.

WAFERS SHOWN DOTTED
FOR CLARITY.

NOTES

1	MSAR-4	
1	CFA-2	A4347
Q'TY./UNIT	MODEL USED ON	ASS'Y. NO.
SCALE 1:1	CODE C	S401-408 (MODEL 13 MODIFIED)

THE CONTENTS OF THIS DRAWING ARE THE EXCLUSIVE PROPERTY OF THE TECHNICAL MATERIEL CORP. ITS UNAUTHORIZED USE OR REPRODUCTION IN WHOLE OR IN PART IS STRICTLY FORBIDDEN.

REQ'D.	ITEM	PART NUMBER	DESCRIPTION	SYMBOL
LIST OF MATERIAL				
MATERIAL ALUMINUM 6063-T6			THE TECHNICAL MATERIEL CORP. MAMARONECK, NEW YORK	
FINISH BLACK ANODIZE			TITLE HEAT SINK, SEMI-CONDUCTOR	
UNLESS OTHERWISE SPECIFIED DIMENSIONS ARE IN INCHES AND INCLUDE CHEMICALLY APPLIED OR PLATED FINISHES		DRAWN RME	DATE 9-30-66	FINAL APPROV <i>[Signature]</i>
		CHECKED <i>[Signature]</i>	DATE	DATE 10/11/66
		ELECT. DES. <i>[Signature]</i>	DATE	HD105
		MECH. DES. <i>[Signature]</i>	DATE 10/17/66	A
			SHEET	REV. LTR.